



AF
1792

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **MATSUZAWA, Minoru, et al.**

Group Art Unit: **1792**

Serial No.: **10/516,949**

Examiner: **JOLLEY, Kirsten**

Filed: **December 16, 2004**

P.T.O. Confirmation No.: **4976**

FOR: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT METHOD

RESPONSE UNDER 37 CFR §1.116

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 30, 2009

Sir:

In response to the Office Action dated **October 30, 2008**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.